

Docket No.: 070759-0042

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	
	:	
Yasuhiro WATANABE, et al.	:	
	:	
Application No.: Not yet assigned	:	Group Art Unit: Not yet assigned
	:	
Filed: December 14, 2006	:	Examiner: Not yet assigned
	:	
For: SEMICONDUCTOR LASER DEVICE AND MANUFACTURING METHOD THEREOF		

**PRELIMINARY AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks / Arguments** begin on page 7 of this paper.